

12/27/00
JC983 U.S. PTO

JC564 U.S. PTO
09/749205
12/27/00

Patent Application Transmittal
(only for new nonprovisional applications under 37 C.F.R. 1.53(b))
Correspondence Address:
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Date: December 27, 2000
Attorney Docket No.: 450100-02915

ASSISTANT COMMISSIONER FOR PATENTS
Box Patent Application
Washington, D.C. 20231
Sir:

With reference to the filing in the United States Patent and Trademark Office of an application for patent in the name(s) of:

Hideki SHIMOMURA, Takashi TOYODA, Katsuki MINAMINO, Osamu HANAGATA, Hiroki SAIJO, Toshiya OGURA

entitled:

CONVERSATION PROCESSING APPARATUS AND METHOD, AND RECORDING MEDIUM THEREFOR

The following are enclosed:

- ☒ Specification (64 pages)
- ☒ 30 Sheet(s) of Drawings
- ☒ 11 Claim(s) (including 3 independent claim(s))
- ☐ This application contains a multiple dependent claim

- ☒ Our check for \$ 710.00, calculated on the basis of the claims as amended by any enclosed preliminary amendment as follows:

Basic Fee, \$710.00 (\$355.00)	\$ 710.00
Number of Claims in excess of 20 at \$18.00 (\$9.00) each:	-0-
Number of Independent Claims in excess of 3 at \$80.00 (\$40.00) each:	-0-
Multiple Dependent Claim Fee at \$270.00 (\$135.00)	-0-
Total Filing Fee	\$ 710.00
Assignment Recording Fee \$40.00	-0-

- ☒ Oath or Declaration and Power of Attorney
 - ☒ New ☐ signed ☒ unsigned
 - ☐ Copy from a prior application (37 C.F.R. 1.63(d))

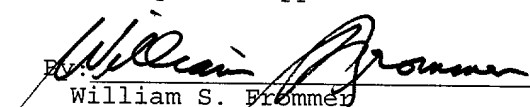
- ☒ Certified copy of each of the following application(s) to substantiate the claim(s) for priority made in the Declaration:

<u>Application No.</u>	<u>Filed</u>	<u>In</u>
11-375767	28 December 1999	Japan

Please charge any additional fees required for the filing of this application or credit any overpayment to Deposit Account No. 50-0320.

Respectfully submitted,

FROMMER LAWRENCE & HAUG LLP
Attorneys for Applicants


William S. Frommer
Reg. No. 25,506

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12-28-00
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December 27, 2000

Assistant Commissioner for Patents
Washington, D.C. 20231

Re: U.S. Patent Application
Applicants: Hideki SHIMOMURA, Takashi TOYODA, Katsuki
MINAMINO, Osamu HANAGATA, Hiroki SAIJO, Toshiya OGURA
Our Ref.: 450100-02915

Dear Sir:

Enclosed are papers constituting the above patent application which is being filed under 37 C.F.R. 1.53 without a signed Declaration. Please accord a filing date and a serial number to such application and inform the undersigned thereof so that a signed Declaration and the surcharge required by 37 C.F.R. 1.16(e) may be duly filed.

Please address all correspondence to:

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Respectfully,



William S. Frommer
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Enclosures